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Wenqiang Peng
Shengyi Li
Chaoliang Guan
Xinmin Shen
Yifan Dail
Zhuo Wang

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Shengyi Li

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Xinmin Shen

Yifan Dail

Zhuo Wang

National University of Defense Technology

College of Mechatronics and Automation

DeYa, Changsha, Hunan Province 410073, China

E-mail: chlguan@nudt.edu.cn

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This article [*Opt. Eng.* **52**(4), 043401 (2013)] was originally published on 15 April 2013 with an error on page 6, Sec. 4, paragraph 2. The first sentence “Figure 8 shows the AFM image of surface microstructure images of $10 \times 10 \mu\text{m}$ on

the silica glass surface...” has been corrected to read “Figure 8 shows the AFM image of surface microstructure images of $5 \times 5 \mu\text{m}$ on the silica glass surface...”

The paper was corrected online on 7 November 2013.